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PATENT

Docket No.: 87289.1741 Customer No. 30734

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

ELWOOD et al.

Serial No. 10/022,194

Filed: December 20, 2001

For:

: Group Art Unit: 2121

Examiner:

EQUIPMENT MONITORING SYSTEM AND METHOD

<u>INFORMATION DISCLOSURE STATEMENT</u>

Commissioner for Patents and Trademarks Washington, D. C. 20231

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Sir:

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In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

No further elaboration is believed necessary. Copies of the prior art are submitted herewith in accordance with 37 C.F.R. §1.98(a).



AUTHORIZATION

This Information Disclosure Statement is being filed before receipt of the first Office Action. No fee is required. The Commissioner is hereby authorized to charge any additional fees which may be required for this submission, or credit any overpayment to deposit account no. 50-2036.

Respectfully submitted,

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ATTY. DOCKET NO. SERIAL NO. RADEMAD LIST OF ART CITED BY APPLICANT 87289.1741 10/022,194 APPLICANT ELWOOD et al. (PTO-1449) FILING DATE **GROUP** 12/20/01 2121 U.S. PATENT DOCUMENTS EXAMINER'S PATENT NO. NAME DATE CLASS SUBCLASS FILING DATE **INITIALS** 6,262,550 4,125,892 4,032,907 318 07/17/01 Kliman et al. 565 12/17/99 В 11/14/78 Fakuda et al. 364 200 06/29/77 06/28/77 Young 340 213R 08/08/75 C D E F G Н Ι J K М Ν MAR 1 8 2002 ō Technology Certer 2100 P Q R s T FOREIGN PATENT DOCUMENTS EXAMINER'S PATENT NO. DATE COUNTRY CLASS SUBCLASS Translation INITIALS ٧ W Ζ AΑ BB CC DD ΕE FF GG OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.) НН II כנ KK LL MM NN **EXAMINER** DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.